

Docket No.: M4065.0706/P706  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Jiutao Li et al.

Application No.: 10/712,106

Confirmation No.: 8216

Filed: November 14, 2003

Art Unit: 1762

For: SILVER SELENIDE SPUTTERED FILMS  
AND METHOD AND APPARATUS FOR  
CONTROLLING DEFECT FORMATION  
IN SILVER SELENIDE SPUTTERED  
FILMS

Examiner: Not Yet Assigned

**REQUEST FOR CORRECTED NOTICE OF RECORDATION OF  
ASSIGNMENT DOCUMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants request that a corrected Notice of Recordation of Assignment Document be issued in the above-identified patent application. The Notice of Recordation of Assignment Document received by the applicants has the following error. The title should read as follows: SILVER SELENIDE SPUTTERED FILMS AND METHOD AND APPARATUS FOR CONTROLLING DEFECT FORMATION IN SILVER SELENIDE SPUTTERED FILMS. This information is correctly indicated on the application as originally filed. A copy of the Notice of Recordation of Assignment Document with the correction noted in red is attached.


Applicants additionally request that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Application No.: 10/712,106

Docket No.: M4065.0706/P706

Dated: August 4, 2004

Respectfully submitted,

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